

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Grimbergen et al.	Group Art Unit: 1763
Application No: 09/595,778	Examiner: Allan W. Olsen
Confirmation No: 6490	
Filed: June 16, 2000	Attorney Docket No: 2077 USA D01/ETCH/SILICON/DAO
Title: APPARATUS AND METHOD FOR MONITORING PROCESSING OF A SUBSTRATE	June 19 <sup>th</sup> , 2008 San Francisco, California

**AMENDMENT FILED WITH RCE**

**VIA ELECTRONIC TRANSMISSION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Examiner Olsen:

This communication is being filed with an RCE. A Notice of Appeal was filed on March 19<sup>th</sup>, 2008, and accordingly this RCE is being timely filed with a one-month extension of time.

**Certificate of Transmission**

I hereby certify that this correspondence is being electronically filed with the U.S. Patent Office, for the attention of the Commissioner for Patents, on the date shown below.

By: *Amy W*  
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Date: June 19, 2008